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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	S. SUNDAR KUMAR IYER, ET AL.)	
)	Group Art Unit: 2813
Serial No.:	09/878,556)	
)	
Filed:	June 11, 2001)	Examiner: Chen, J.
)	
For:	METHOD OF FORMING VARIABLE OXIDE THICKNESS ACROSS SEMICONDUCTOR CHIPS)	Confirmation No.: 3210
)	

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed September 7, 2004, please amend
the Application as follows:

DO NOT Enter
10/27/04
